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RECEIVED
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Cleopatra Cabuz et al.

Examiner: Unknown

Serial No.: 09/749,171

Group Art Unit: 1765

Filing Date: December 27, 2000

For: THIN SILICON MICROMACHINED STRUCTURES

Docket No.: 1100.1116101 (H16-26635)

Assistant Commissioner
for Patents
Washington, D.C. 20231

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS
BEING DEPOSITED WITH THE UNITED STATES POSTAL
SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE
ADDRESSED TO: ASSISTANT COMMISSIONER FOR
PATENTS, WASHINGTON, D.C. 20231

25th DAY OF MAY 2001.

Brian N. Tufte

Dear Sirs:

INFORMATION DISCLOSURE STATEMENT

Pursuant to the obligations of candor and good faith imposed by 37 C.F.R. 1.56, the documents listed on the attached PTO-1449 are hereby disclosed.

No representation is intended to be made hereby that any of the cited references establishes, by itself or in combination with other information, a prima facie case of unpatentability of any claim of the present case.

Respectfully submitted,

Cleopatra Cabuz et al.

By their attorney

Brian N. Tufte, Reg. No. 38,638

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Dated: May 25, 2001